



Equipment Information

Make: CRESTEC

Model: CABL-9000C

Description:

Electron beam lithography system

SEIKO SEIKI STP-301 Turbomolecular pump

KASHIYAMA NeoDry 30-E

PIC-050A-IP Control unit

20L/60L Ion pump

30L/S912—7135S Pump data

KEITHLEY 6485 Picoammeter

IWATSU ST-3708 Laser displacement meter

M-UPS-030AD2S Uninterruptible Power Supply (UPS)

DAN-TAKUMA TECHNOLOGIES Thermal controller

APCO AIP-38A Ionpump power supply

2008 vintage.